Busine	ss Unit & Req. #_	194016132	ECCN	:	Total Amount: \$1,	176,000.00
Note:	This Sole Source Certification will become a public document, open to public inspection; therefore, you should be certain all material facts are true, relevant and clearly understandable.					
	SOLE SO		the following i	s submitted in supp	ity of Florida Rule No. 6C1-3.02 port of this request for authorit ems available from only one s	y to
Note:	be provided. Best of supply, best p	st Price alone cannot rice must be determ	be used for sole so ined through the co	ource. If the item/se empetitive bid proce		nan one source
			aiyo Nippon Sans	o thru MITSUI KN	IOWLEDGEINDUSTRY CO	E,LTD.
Contact Person: Kunihiko Narita Address: Atago Green Hills MORI Tower 2-5-I Atago, Minato ku, Tokyo 105-6215 Japan						
	·					
	•	_	-		narita-kunihiko@mki.co.jp	
B. Describe in lay language, what the item/service is and how it is to be used in your area of research. (cont. P2)						
The item is an metal organic chemical vapor deposition (MOCVD) tool for epitaxial growth of Ill-nitride materials, including a high temperature delivery system for low vapor pressure metal organic precursors. The reactor will be used to grow Ill-nitride films to support research in Ill-nitrides for rf applications, power electronics, optoelectronics, ferroelectrics and non-linear optics. The materials of interest are GaN, AlGaN, BN, and (very importantly) AlScN along with other transition metal nitrides. For these last two materials systems, all precursors have very low vapor pressures and CANNOT be grown in a conventional MOCVD. These last two areas are NEW areas for MOCVD and will be a large portion of my research thrusts.						
C. What feature or special condition of this commodity/service is unique and cannot be obtained from any other source? Why are these features or special conditions important to the research? (cont. P2)						
re-des group would	sign of the flow flange. This is globally that can do this). The support the DARPA propose	s REQUIRED for any research in he reactor itself is also rated for gi al we submitted on AIN growth). T	AlScN and transition metal nitr rowth up to 1350C, which is ne The quote also includes in situs	ides, and is unique. This will be cessary for high quality AIN and strain and temperature monitori	e metal organic precursors, including delivery, ce the first tool to enable this growth in the US (the d BN, for power electronic and extreme environing of the films, from a trusted manufacturer. It is nables mutli-stacks of different materials and co	ere is one other research nent applications (and also a horizontal
If N	lo, is it available f	ourchased directly from rom more than one d rom more than one de	lealer?	☐ Yes	□ No ■ No nt. P2)	
	es: 1) Did you ob	s requisition, did you tain quotes from the	other sources?	☐ Yes ■ No	■ Yes □ No o If Yes, attach copies. o If No, justify the additional	cost helow
	2)131113 Vel	idoi 3 price lower tria	in the other source.	<u> </u>	o ii ivo, justily the additional	cost below.
F. Wha	What efforts have been made to obtain the best price possible? Why do you feel this price is fair and reasonable? (cont. P2)					
the I	I have haggled over the pricing of this tool with the company for over six months, and they have brought the price down as they would like to place it in the US with a well-known researcher who is willing to collaborate with them and publish all results with the tool. The original price estimate was ~\$2 M. The <\$1.2 price is below the price for any other standard systems, not to mention that it includes in situ monitoring for stress and strain (normally \$250K), AND a new, novel high temperature delivery system which will allow us to move into materials that have been impossible by MOCVD.					
	•	certify the above to be have a financial inte		•	our knowledge and belief and	the user and /
DEPARTMENT APPROVAL			PURCHASING APPROVAL			
I hereby certify the validity of the information and feel confident the Sole Source Certification will meet University criteria and would withstand any audit or vendor protest.			This acquisition is approved as a non-competitive purchase.			
Jennifer Hite Digitally signed by Jennifer Hite Date: 2024.11.19 07:20:47 -05'00' 11/19/2024				Digitally signed by Vincent Anderson Date: 2024.11.19 07:45:28 -05'00'		
	al Investigator's S		Date	Purchasing Coord	dinator Signature	Date
FAILURE TO FILE A PROTEST IN ACCORDANCE WITH BOARD OF GOVERNORS (BOG) REGULATION 18.002 OR FAILURE TO POST THE BOND OR OTHER SECURITY AS REQUIRED IN THE BOG REGULATION 18.002 AND 18.003(3) SHALL CONSTITUTE A WAIVER OF PROTEST PROCEEDING.			N. J. Her Purchasing Author	prized Signature	11/19/2024 Date	

Sole Source Certification (Continued) Please use the following sections to continue documentation if needed.					
B. continued					
C. continued					
D. continued					
E. continued					
F. continued					

FA-PDS-SOLSRC 12/2018